

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Applicants:

Date: February 14, 2008

Haight et al.

Group Art Unit: 1793

Serial No.: 09/933,461

Examiner: Geoffrey S. Evans

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Docket No.: YOR919980510US2

For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF
MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION DATED 11/2/2007

Amendments to the claims begin on 2 page of this paper.

Remarks begin on 17 page of this paper.